PTO/SB/08a (08-03)

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Substitute for form 1449A/PTO			Complete if Known		
			Application Number	10/571,246	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			Filing Date	December 5, 2006	
			First Named Inventor	Rudhard et al.	
			Art Unit	2829	
(Use as many sheets as necessary)		Examiner Name	Ming Hung HUNG		
Sheet	1	of 1	Attorney Docket Number	10191/4346	

U.S. PATENT DOCUMENTS					
Examiner Initials *	Cite No. ⁵	Document Number Number - Kind Code ² (<i>if</i> <i>known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

		FOREIGN PA	ATENT DOCUME	V15		_
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111111111111111111111111111111111111111		B. TiLLACK et al., "Monitoring of Deposition and Dry Etching of Si/SiGe Multiple Stacks", J. Vac. Sci. Technol. B14(1), Jan/Feb 1996, 1996 American Vacuum Society, pp. 102-105.				
		C.S. PREMACHANDRAN et al., "A Novel Elec MEMS Packaging", 2003 Electronic Componer			s Interconnect For 3D	жения при

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